

**PATENT APPLICATION****RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 3723****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Junichi UENO

Group Art Unit: 3723

Application No.: 10/549,453

Examiner: R. ROSE

Filed: September 14, 2005

Docket No.: 125333

For: WAFER-HOLDING CARRIER, DOUBLE-SIDE POLISHING APPARATUS USING  
THE SAME, AND DOUBLE-SIDE POLISHING METHOD OF WAFER

OK TO ENTER: /RR/

02/15/2008

**REQUEST FOR RECONSIDERATION AFTER FINAL REJECTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the October 31, 2007 Office Action, reconsideration of the rejections is respectfully requested in light of the following remarks.